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Electronic properties of perovskite strontium chromium oxyfluoride epitaxial thin films fabricated via low-temperature topotactic reaction

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Perovskite chromium oxyfluoride $SrCrO_{2.6}F_{0.4}$ epitaxial thin films were fabricated via low-temperature topotactic fluorination of $SrCrO_{2.8}$ precursor with polyvinylidene fluoride as a fluorine source. The obtained $SrCrO_{2.6}F_{0.4}$ thin film had a different chemical composition than that of bulk polycrystalline $SrCrO_{2.8}F_{0.2}$, possibly due to the higher reactivity of such thin film. Both the precursor and fluorinated thin films containing $Cr^{3.6+}$ exhibited insulating behavior with band gaps of ~ 0.6 eV, in contrast to metallic $SrCrO_3$ with Cr^{4+} at 300 K. The experimentally observed valence and conduction bands of the $SrCrO_{2.8}$, $SrCrO_3$, and $SrCrO_{2.6}F_{0.4}$ thin films suggested that the spectral weight transfer from the coherent part to the incoherent part with the reduction of Cr valences was caused by strong electron correlation effects. This study offers a fundamental understanding of the fluorine doping effects on a crystalline structure and the correlated electronic performance of chromium oxides.

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I. INTRODUCTION

Perovskite-type chromium oxides exhibit unique physical properties due to the strong Cr 3d–O 2p interaction. A typical example is $SrCrO_3$ containing Cr^{4+} (3 d^2), where the Cr 3dstates split into t_{2g} and e_g orbitals and two valence electrons occupy the nearly triply degenerated t_{2g} orbitals [1–3]. Cubic SrCrO₃ exhibits antiferromagnetic metallic behaviors because its transport property lies in the crossover region between itinerant and localized carriers [1,2]. Substituting La³⁺ for Sr²⁺ in SrCrO₃ dopes electrons in the system and induces an electronic phase transition from antiferromagnetic metal to antiferromagnetic insulator [4–6]. Introduction of oxygen vacancies and insertion/substitution of H⁻ ions into SrCrO₃ have been attempted to alter its electronic properties [7–9]. Cubic metallic SrCrO₃ can be reversibly transformed into rhombohedral semiconducting SrCrO_{2.8} by changing the annealing atmosphere between vacuum (SrCrO₃ \rightarrow SrCrO_{2.8}) and air $(SrCrO_{2.8} \rightarrow SrCrO_3)$ at relatively low temperatures (250-500 °C), as reported in the cases of epitaxial films and bulk polycrystals [7,8]. Rhombohedral SrCrO_{2.8}, which has {111}-oriented planes of SrO₂ with adjacent layers of tetrahedrally coordinated Cr⁴⁺, exhibits fast O²⁻ diffusion [7]. SrCrO₂H synthesized by a high-pressure method is known to be an antiferromagnetic insulator with a Néel temperature (T_N) of 380 K [9]. This T_N value is the highest among chromium oxides and can be reasonably explained by the tolerance factor [9].

The physical properties of perovskite-type Cr oxides can be readily modified through topotactic fluorination because insertion or substitution of F⁻ ions provides additional holes or electrons to the Cr ions, respectively. For example, layered La₂SrCr₂⁴⁺O₇F₂ and nonlayered SrCr^{3.8+}O_{2.8}F_{0.2} have been synthesized in polycrystalline form by topotactic fluorination of La₂SrCr₂³⁺O₇ using CuF₂ [10] and SrCr⁴⁺O₃ with polyvinylidene fluoride (PVDF) [11], respectively. These oxyfluorides exhibit antiferromagnetism with T_N of 140 and 230 K, respectively [10,11], which is much higher than that reported for $SrCrO_3$ ($T_N = 35-40 \,\mathrm{K}$) [12]. The fluoride ion substitution for the oxide ion sites would directly affect the connectivity of the Cr-anion network responsible for electrical conduction. However, electrical conduction characteristics and electronic states of perovskite-type Cr oxyfluorides have not yet been discussed.

In order to obtain the intrinsic electronic properties of perovskite-type Cr oxyfluorides, phase-pure and single-crystalline samples are desired. Use of epitaxial thin films as precursors for topotactic fluorination allows the preparation of such oxyfluoride samples in thin film form [13]. Indeed, PVDF-mediated topotactic fluorination reactions have been applied to various transition-metal oxide epitaxial thin films so far, such as $La_{1-x}Sr_xMnO_{3-\delta}$, $SrFeO_{3-\delta}$, $SrCoO_{2.5}$, (La, Nd)NiO₃, BaBiO₃, and layered Sr_2RuO_4 [13–20]. In addition, thin-film samples are generally more reactive than bulk samples because of larger surface areas and smaller

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volumes [13]. Here, we report fluorine doping in perovskite-type $SrCrO_{2.8}$ epitaxial thin films via topotactic fluorination using PVDF. We obtained perovskite-type $SrCrO_{2.6}F_{0.4}$ epitaxial thin films, which had higher fluorine content than that in bulk polycrystalline $SrCrO_{2.8}F_{0.2}$ [11]. Based on the results of resistivity and optical and electronic spectroscopy measurements, we discuss the transport properties and electronic structure of $SrCrO_{2.6}F_{0.4}$ thin film in comparison with those of $SrCrO_{2.8}$ and $SrCrO_{3}$. It offers a fundamental understanding of the fluorine doping effects on a crystalline structure and the correlated electronic performance of chromium oxides.

II. EXPERIMENTAL

Precursor SrCrO_{2.8} thin films were grown on LaAlO₃ (001) (LAO, Shinkosha Co.) substrates by pulsed-laser deposition (PLD) technique, using a KrF excimer laser (wavelength $\lambda =$ 248 nm) with an energy of 1.5 J/cm²/shot and a repetition rate of 2 Hz. Polycrystalline SrCrO₃ ceramic pellets used as PLD targets were synthesized using a high-pressure method. A stoichiometric mixture of SrO (prepared by heating SrCO₃ at 1300 °C in an O₂ gas atmosphere) and CrO₂ (Aldrich) was finely ground, then loaded into a Pt capsule, and placed in a high-pressure cell. This cell was then heated at 6 GPa and 1000 °C for 1 h and then quenched to room temperature by turning off the heat before pressure was released. During each PLD run, the substrate temperature and oxygen partial pressure were set at 750 °C and 1×10^{-7} Torr, respectively. The obtained SrCrO_{2.8} thin films were further subjected to fluorination using PVDF (Fluorochem Ltd.) under Ar gas flow at reaction temperatures (T_f) of 100 - 400 °C for 12 h. Following the methodology previously developed by our group [13,16,18–20], the films were covered with Al foil during fluorination to avoid the adhesion of the charcoal-like residue produced by the decomposition of the PVDF. The fluorinated films were rinsed with ethanol. Oxidized films were prepared by annealing the SrCrO_{2.8} precursor thin films at 250 °C in air for 2 h. The typical thickness of the films was evaluated at \sim 50 nm using x-ray reflectivity (Bruker AXS D8 DISCOVER).

Crystal structures of the films were characterized by x-ray diffraction (XRD, Bruker AXS D8 Discover) with Cu Ka radiation. Chemical compositions were determined using an energy-dispersive x-ray spectrometer (EDS, JEOL JED-2300) in conjunction with a scanning electron microscope (JEOL JSM-7100F), which was operated at an electron accelerating energy of 2.5 keV to reduce any substrate contribution. The depth profiles of the chemical compositions were analyzed by employing x-ray photoemission spectroscopy (XPS, JEOL JPS-9010MC) with Ar⁺-ion etching. Surface morphology was characterized by atomic force microscopy (AFM, SII SPI4000). Cr 2p and valence-band XPS and O K-edge xray absorption spectroscopy (XAS) spectra were measured at beamline BL-2A MUSASHI of the KEK-PF synchrotron facility. The Cr 2p and valence-band XPS spectra were measured at 300 K using a VG-SCIENTA SES-2002 electronenergy analyzer with an energy resolution of 300 meV at a photon energy of 1200 eV. The Fermi level of the samples was set as that of an in situ evaporated gold foil which was in electrical contact with the sample. The O K-edge XAS spectra were measured at 300 K by the total-electron-yield method.

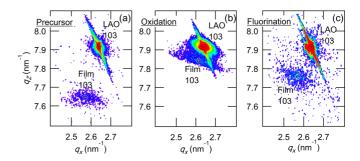


FIG. 1. Reciprocal space maps of the (a) SrCrO_{2.8} precursor film, (b) oxidized film, and (c) fluorinated film.

Before the synchrotron XPS and XAS measurements, the films were kept in a high-vacuum atmosphere ($<3 \times 10^{-7}$ Pa) for more than 2 h to remove surface gas contaminants as much as possible. In-plane electrical resistivities (ρ) were measured by the four-terminal method with silver electrodes, using Physical Property Measurement System (Quantum Design Co.), in which the maximum measurement range for ρ was 100 Ω cm. Optical spectra were measured at 300 K using an ultraviolet—visible—near-infrared (UV-Vis-NIR) spectrometer (Jasco V670DS) and a Fourier transform infrared spectrometer (FTIR, Jasco FT/IR-4600).

III. RESULTS AND DISCUSSION

Fluorination of the $SrCrO_{2.8}$ precursor thin film with PVDF was conducted at $T_f = 200-350$ °C (Supplemental Material, Fig. S1) [21]. Figure 1 shows reciprocal space maps around the 103 diffraction of the SrCrO_{2.8} precursor film, the oxidized film at 250 °C in air, and the fluorinated film with PVDF at 250 °C on the LAO substrates. The q_x values of the films were different from that of the LAO substrate, indicating that all the films were relaxed from the LAO substrates. No secondary phases were detected in any of the films in the angle range of 10° - 60° , confirmed by the 2θ - θ XRD patterns at a tilting angle of $\chi = 90^{\circ}$ (Supplemental Material, Fig. S2) [21]. Note that the SrCrO_{2.8} precursor thin film had a tetragonal structure, as seen from the φ scan profile around the (103) reflection (Supplemental Material, Fig. S3) [21]. The a- and c-axes lengths of the precursor film were calculated as 0.389 and 0.392 nm, respectively, which were different from those of the strained $SrCrO_{2.8}$ films ($a = 0.382 \,\mathrm{nm}$, $c = 0.392 \,\mathrm{nm}$) [7]. This discrepancy may be due to the difference in lattice strain and/or crystalline symmetry. After the oxidation, the a- and c-axes lengths decreased to 0.383 and 0.383 nm, respectively, possibly due to the increase of the valence number of the Cr ions. On the other hand, the a- and c-axes lengths of the fluorinated film were calculated as 0.389 and 0.387 nm, respectively, although these lengths are larger than those of bulk cubic $SrCrO_{2.8}F_{0.2}$ (a = 0.3853 nm) [11].

In order to examine the chemical composition of the films, EDS and XPS measurements were performed. Figure 2 shows the 2.5-keV EDS spectra of the SrCrO_{2.8} precursor and the fluorinated films, where the spectra were normalized by the area of the Sr $L\alpha$ peak. The EDS spectra near O $K\alpha$, Cr $L\alpha$, and F $K\alpha$ and the fitting results obtained by least-square fitting are shown in the inset of Fig. 2 and Fig. S4 [21], respectively.

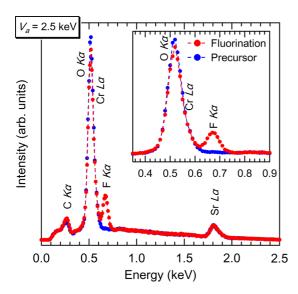


FIG. 2. 2.5-keV EDS results of the SrCrO_{2.8} precursor film (blue line) and the fluorinated films reacted with PVDF at 250 °C for 12 h (red line). The inset shows a close-up near O $K\alpha$, Cr $L\alpha$, and F $K\alpha$.

In the fluorinated film, an F $K\alpha$ peak was observed with a concurrent decrease in the intensity of the O $K\alpha$ peak, indicating that incorporation of fluorine into the anion sites and partial removal of oxygen took place simultaneously during the fluorination process. Figure 3 depicts the elemental depth profiles in the film fluorinated at 250 °C, determined from the peak areas of the F 1s, Sr 3d, Cr $2p_{3/2}$, La 4d, and Al 2p measured by XPS combined with Ar⁺-ion etching. As seen in Fig. 3, the signal intensity of F was almost constant at 5–40 nm and slightly increased near the interface between

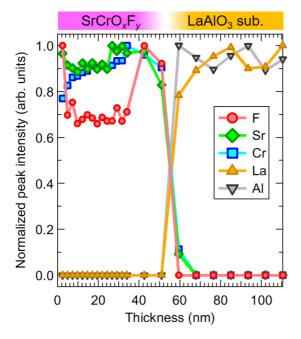


FIG. 3. Normalized concentration-depth profiles of the film fluorinated at 250 °C obtained from the F 1s (red circle), Sr 3d (green diamond), Cr $2p_{3/2}$ (blue square), La 4d (orange triangle), and Al 2p (black inverted triangle) XPS spectra.

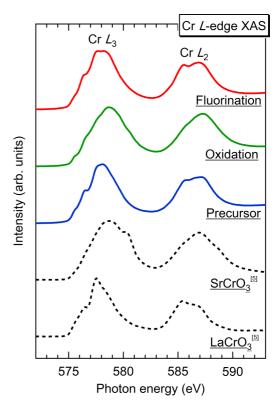


FIG. 4. Cr L-edge XAS spectra of the SrCrO_{2.8} precursor film (blue line), the oxidized film annealed at 250 °C in air (green line), and the film fluorinated with PVDF at 250 °C (red line). The reference spectra of SrCrO₃ (Cr⁴⁺) and the LaCrO₃ (Cr³⁺) are also shown in the figure.

the film and the substrate. These results suggest that the F ions diffused over the entire film. On the other hand, in the substrate region where the intensities of La and Al abruptly increased, F was not detected, indicating that the diffusion of F into the LAO substrate was negligible. Furthermore, the root-mean-square surface roughness values of the SrCrO_{2.8} precursor and fluorinated films were determined by AFM measurements to be 0.59 and 1.13 nm, respectively (Supplemental Material, Fig. S5) [21].

To examine the changes of the valence numbers of Cr by the oxidation and fluorination, we performed Cr L-edge XAS measurements, as shown in Fig. 4. It is known that the shape of Cr L-edge XAS spectrum of Cr4+ is very different from that of Cr³⁺ and that the valence number of Cr can be roughly estimated from the linear combination of Cr⁴⁺ and Cr³⁺ XAS spectra [22]. As seen in Fig. 4, the positions of the highest L_3 and L_2 peaks (578.7 and 587 eV) of the oxidized film were almost the same as those of the SrCrO₃ reference, indicating that the oxidized film had Cr⁴⁺. Thus, we determined the chemical formula of the oxidized film as SrCrO₃. Note that the peak at ∼582 eV was not observed in the oxidized film, which may be due to a change in Cr-O bond lengths associated with lattice strain and/or degraded crystallinity. On the other hand, the valence numbers of Cr in both precursor and fluorinated films were estimated to be 3.6 \pm 0.1 so as to reproduce the energy positions of the highest Cr L-edge peak by linearly combining the spectra of the oxidized

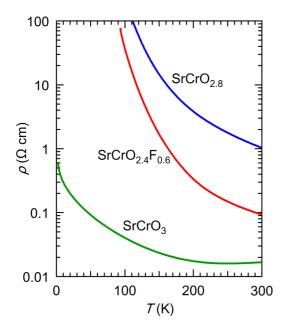


FIG. 5. ρ -T curves for the SrCrO_{2.8} (blue line), SrCrO_{2.6}F_{0.4} (red line), and SrCrO₃ (green line) films.

film (Cr⁴⁺) and LaCrO₃ reference [5] (Cr³⁺) in Fig. S6 [21]. Assuming x + y = 3 in SrCrO_xF_y, the chemical composition of the fluorinated film can be estimated as SrCrO_{2.6}F_{0.4}. Note that our fluorinated film had a higher fluorine content than polycrystalline bulk sample, SrCrO_{2.8}F_{0.2} [11], probably reflecting a higher reactivity of thin films than bulk because of larger surface areas and smaller volumes. Hereafter, the fluorinated film is referred to as SrCrO_{2.6}F_{0.4}.

Figure 5 plots the resistivity (ρ) of the SrCrO_{2.8}, SrCrO₃, and $SrCrO_{2.6}F_{0.4}$ films as a function of temperature (T). The $\rho(300 \,\mathrm{K})$ value of the SrCrO_{2.8} film was $\sim 1.0 \,\Omega$ cm, which is two orders of magnitude higher than that of the SrCrO₃ film, $\sim 1.7 \times 10^{-2} \Omega$ cm, and one order of magnitude higher than that of the SrCrO_{2.6}F_{0.4} film, \sim 9.3 × 10⁻² Ω cm. The ρ -T curve of the SrCrO₃ film showed metallic behavior $(d\rho/dT > 0)$ in the range of 250–300 K. Notably, the $\rho(300 \,\mathrm{K})$ value and metal-insulator transition (MIT) temperature of the SrCrO₃ film are higher than those of the fully strained SrCrO₃ film, at $1.3 \times 10^{-3} \Omega$ cm and 50 K, respectively [2], which is likely due to the differences in magnitude of the epitaxial strain and/or crystallinity. On the other hand, the ρ -T curves of the SrCrO_{2.8} and SrCrO_{2.6}F_{0.4} films showed insulating behavior $(d\rho/dT < 0)$. These results indicate that SrCrO₃ undergoes MIT by substituting F for O, similar to the MIT associated with the introduction of oxygen vacancies.

Next, we discuss how the electronic structure changes with fluorination. Figure 6 shows the optical absorption spectra $[\alpha(\omega)]$ of the $SrCrO_{2.8}$ and $SrCrO_{2.6}F_{0.4}$ films, as calculated using the relation $\alpha(\omega) = -\ln[T(\omega)_{\rm film+LAOsubstrate}/T(\omega)_{\rm LAOsubstrate}]/t$, where $T(\omega)$ is the optical transmittance spectrum, and t is the thickness of the thin film. The UV-VIS-IR transmittance and reflectivity spectra of the $SrCrO_{2.8}$ and $SrCrO_{2.6}F_{0.4}$ films and LAO substrate are shown in Supplemental Material, Fig. S7 [21]. As seen in Fig. 6, the $SrCrO_{2.6}F_{0.4}$ film exhibited

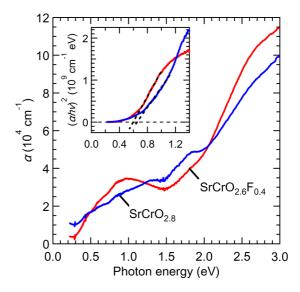


FIG. 6. Optical absorption spectra of the $SrCrO_{2.8}$ (blue line) and $SrCrO_{2.6}F_{0.4}$ films (red line). The inset plots the $(\alpha h\nu)^2 vsh\nu$ curves.

absorption peaks at 1 and 2.7 eV. In a semiconductor, the optical coefficient is known to follow the relation $(\alpha h \nu)^n = A(h \nu - E_g)$ near the band edge, where E_g is the energy band gap, $h \nu$ is the photon energy, and n is 2 for direct band gap or 1/2 for indirect band gap. The absorption spectra of both SrCrO_{2.8} and SrCrO_{2.6}F_{0.4} could be adequately fitted by $(\alpha h \nu)^2$ rather than $(\alpha h \nu)^{1/2}$, suggesting that they have direct band gaps. The inset of Fig. 6 shows the $(\alpha h \nu)^2 vs h \nu$ curves for the two films. By extrapolating the linear portions of the curves to $(\alpha h \nu)^2 = 0$, the optical band-gap values are evaluated as ~ 0.6 eV for both SrCrO_{2.8} and SrCrO_{2.6}F_{0.4}.

The electronic structures of the valence and conduction bands were probed by synchrotron XPS and O *K*-edge XAS measurements. Figure 7(a) shows the valence-band XPS

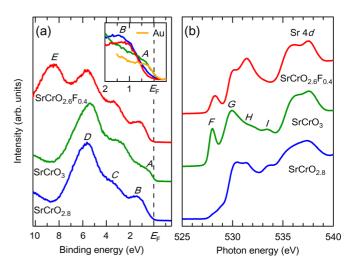


FIG. 7. (a) Valence-band XPS spectra of the SrCrO_{2.8} (blue line), SrCrO₃ (green line), and SrCrO_{2.6}F_{0.4} films (red line). The inset of (a) shows the valence-band spectra close to the Fermi level, along with the spectrum from Au foil for energy calibration purposes (gold line). (b) O *K*-edge XAS spectra of the SrCrO_{2.8} (blue line), SrCrO₃ (green line), and SrCrO_{2.6}F_{0.4} films (red line) measured at $\theta_{\rm inc}=60^{\circ}$.

spectra of the SrCrO_{2.8}, SrCrO₃, and SrCrO_{2.6}F_{0.4} films. The valence-band spectrum of the SrCrO_{2.8} film mainly consists of three structures, labeled as B, C, and D. According to previous density-functional theory (DFT) calculations and XPS measurements [2], the structures B, C, and D can be assigned as incoherent parts of the Cr 3d t_{2g} , O 2p nonbonding, and O 2p bonding bands, respectively. In the SrCrO₃ film, the structures C and D are rigidly shifted to lower binding energies by 0.25 eV, thereby representing the chemical-potential shift associated with electron doping. Near the Fermi level (E_F) , as shown in the inset of Fig. 7(a), the structure B was suppressed and a coherent part of Cr 3d t_{2g} (structure A) evolved owing to the strong electron correlation effects, similar to other strongly correlated metallic transition-metal oxides, such as $SrVO_3$, $La_{1-x}Sr_xMnO_3$, and $Ca_{1-x}Sr_xRuO_3$ [23–25]. On the other hand, in the $SrCrO_{2.6}F_{0.4}$ film, a gap opened at E_F and the structure B was enhanced, which was consistent with the insulating behavior of the SrCrO_{2.6}F_{0.4} film. The positions of the structures C and D were the same as those of the SrCrO_{2.8} film, which was consistent with the XAS results, showing that $SrCrO_{2.8}$ and $SrCrO_{2.6}F_{0.4}$ films had the same Cr valence numbers. In addition, a spectral structure E appeared around the binding energy of 7–10 eV. Considering higher electronegativity of fluorine than oxygen, the structure E is assignable to the F 2p bonding states.

Figure 7(b) shows the O K-edge XAS spectra of the SrCrO_{2.8}, SrCrO₃, and SrCrO_{2.6}F_{0.4} films measured using linearly polarized light, where the angle between the incident beam and the surface normal (θ_{inc}) was set at 60°. The O Kedge XAS spectra correspond to transitions into unoccupied O 2p states hybridized with Cr 3d and Sr 4d. As seen in Fig. 7(b), the peaks at 527–534 eV and those at 534–540 eV can be assigned to the Cr 3d-derived states (structures F, G, H, and I) and Sr 4d-derived states, respectively, by comparing the O K-edge XAS spectrum of the SrCrO₃ film [5]. Referring to the reported DFT calculations of SrCrO₃ and CrO₂ [2,26], we assigned the structure F to excitations of the unoccupied $t_{2g} \uparrow$ band, the structures G and H to the combination of unoccupied $e_g \uparrow$ and $t_{2g} \downarrow$, and the structure I to the unoccupied $e_g \downarrow$ band. The structure F of the SrCrO_{2.6}F_{0.4} film is located at 528.3 eV, which is 0.3 eV higher than that of the SrCrO₃ film. This suggests spectral weight transfer from the coherent part to the incoherent part with fluorination due to strong electron correlation effects. Moreover, the peak intensity of the structure F of the $SrCrO_{2.6}F_{0.4}$ film was smaller than that of the $SrCrO_{3}$ film. This is mainly due to the decrease in Cr valence number, as seen in the case of $La_{1-x}Sr_xCrO_{3}$ thin films [5]. On the other hand, the $SrCrO_{2.6}F_{0.4}$ film showed a larger intensity than the $SrCrO_{2.8}$ film, although the Cr valence numbers were the same. This may be due to local distortion of Cr-O bonds, because XAS using linearly polarized light is sensitive to the angle between the incident beam and the axes of O 2p orbitals due to the dipole selection rule [27].

IV. CONCLUSION

We fabricated chromium oxyfluoride epitaxial thin films by PVDF-mediated fluorination of SrCrO_{2.8} precursor and investigated the effects of fluorine doping on the electronic properties. After reacting with PVDF, the SrCrO_{2.8} precursor film grown on an LAO substrate was transformed into SrCrO_{2.6}F_{0.4}, and its fluorine content was higher than that of bulk polycrystalline SrCrO_{2.8}F_{0.2}, hence reflecting the higher reactivity of thin films. The ρ -T curves of the SrCrO_{2.8} and SrCrO_{2.6}F_{0.4} films with Cr^{3.6+} showed insulating behavior, which was in stark contrast to SrCrO₃ with Cr⁴⁺ exhibiting metallic transport properties at 300 K. The optical E_g values of the SrCrO_{2.8} and SrCrO_{2.6}F_{0.4} were evaluated as \sim 0.6 eV by UV-VIS-IR measurements. The results of XPS and XAS measurements suggested spectral weight transfer from the coherent part to the incoherent part, accompanied by the reduction of Cr valences from Cr⁴⁺ to Cr^{3.6+} due to strong electron correlation effects. These findings can help understand the fluorine doping effects on crystalline and electronic structures of unknown chromium oxyfluorides.

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